



2828.
#5/D/King

Attorney Docket No. ABACP0106US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Applicants: Andreas Wittmann et al.

Serial No: 09/993,824

Filed: November 6, 2001

Title: ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS

Art Unit: 2828

Examiner: Dung T. Nguyen

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST
(REVOCATION OF PRIOR POWERS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The assignee of the entire right, title and interest of the above identified patent application, hereby revokes all powers of attorney previously given and hereby appoints the following attorneys to prosecute and transact all business in the Patent and Trademark Office connected with the above referenced application.

Mark D. Saralino, Registration No. 34,243

Send correspondence and direct telephone calls to:

Mark D. Saralino, Esq.
RENNER, OTTO, BOISSELLE & SKLAR
1621 Euclid Avenue, 19th Floor
Cleveland, Ohio 44115

Tel: 216-621-1113
Fax: 216-621-6165

The undersigned has reviewed all the documents in the chain of title of the patent application identified above and, to the best of the undersigned's knowledge and belief, title is in the assignee identified below.

A statement under 37 CFR 3.73(b) is submitted herewith.

The undersigned further declares that he is empowered to act on behalf of the assignee, and that all statements made herein of his own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the like so made, are punishable by fine or imprisonment, or both, under Section 1001, Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

BOOKHAM TECHNOLOGY PLC

Date: 2 June 2003

By: Haydn Jones
Haydn Jones
Intellectual Property Manager

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JUN 11 2003
TC 2800 MAIL ROOM



Docket No. ABACP0106US

STATEMENT UNDER 37 CFR 3.73(b)

Applicant/Patent Owner: Andreas Wittmann, et al.

Application No./Patent No.: 09/993,824 Filed/Issue Date: November 6, 2001

Entitled: ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS

BOOKHAM TECHNOLOGY PLC, a Corporation

(Name of Assignee)

(Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)

states that it is:

1. ☒ the assignee of the entire right, title, and interest; or
2. ☐ an assignee of less than the entire right, title and interest.
The extent (by, percentage) of its ownership interest is _____ %

in the patent application/patent identified above by virtue of either:

- A. ☐ An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel _____, Frame _____, for which a copy thereof is attached.

OR

- B. ☒ A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as shown below:

1. From: Andreas Wittmann, et al. To: Nortel Networks Corp.
The document was recorded in the United States Patent and Trademark Office at Reel 012329, Frame 0214, or for which a copy thereof is attached.
2. From: Nortel Networks Corp. To: BOOKHAM TECHNOLOGY PLC
The document was recorded in the United States Patent and Trademark Office at Reel _____, Frame _____, or for which a copy thereof is attached.
3. From: _____ To: _____
The document was recorded in the United States Patent and Trademark Office at Reel _____, Frame _____, or for which a copy thereof is attached.

☐ Additional documents in the chain of title are listed on a supplemental sheet.

☒ Copies of assignments or other documents in the chain of title are attached.

[NOTE: A separate copy (i.e., the original assignment document or a true copy of the original document) must be submitted to Assignment Division in accordance with 37 CFR Part 3, if the assignment is to be recorded in the records of the USPTO. See MPEP 302.08]

The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.

2 June 2003
Date

Haydn Jones

Typed or printed name

Haydn Jones
Signature

Intellectual Property Manager

Title

JUN 11 2003
TC 2800 MAIL ROOM

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AMENDMENT TO THE PATENT ASSIGNMENT AGREEMENT

This Amendment (this "Amendment"), effective as of November 8, 2002, to the Patent Assignment Agreement made on November 8, 2002 (the "PAA") is hereby made by and among NORTEL NETWORKS CORPORATION, a corporation duly incorporated under the laws of Canada, having its executive offices at 8200 Dixie Road, Suite 100, Brampton, Ontario L6T 5P6 Canada, and each of its subsidiaries that are listed on the signature pages hereto (collectively, the "Assigning Parties") and BOOKHAM TECHNOLOGY PLC, a public limited company incorporated under the laws of England and Wales having its executive offices at 90 Milton Park, Abingdon, Oxfordshire OX14, 4RY United Kingdom (the "Assignee") (each of the Assigning Parties and Assignee, a "Party" and, collectively, the "Parties").

WHEREAS, the Parties, having entered into the PAA, desire to amend the PAA to update the schedule of patents, patent applications and invention disclosures attached thereto.

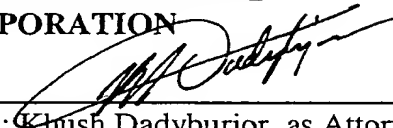
NOW THEREFORE, in consideration of the foregoing premises and the mutual terms and conditions set forth herein, and for U.S. \$1.00 (ONE DOLLAR) and other good and valuable consideration, receipt and adequacy of which is hereby acknowledged, the Parties hereby agree that the PAA be, and is, amended as follows:

1. Schedule A of the PAA is deleted in its entirety and replaced with the new Schedule A attached hereto.
2. Except as expressly amended by this Amendment, all of the terms, covenants and conditions of the PAA shall remain unamended and in full force and effect.
3. This Amendment is hereby incorporated in, and forms a part of, the PAA. For the avoidance of doubt, this Amendment shall be governed by and enforced in accordance with the laws of the State of New York, without giving effect to any conflicts of law principles.
4. This Amendment shall be binding on, and shall inure to the benefit of, the Parties and their respective successors and assigns.
5. This Amendment may be executed in any number of counterparts, each of which shall be deemed to be an original but all of which shall constitute one and the same instrument.

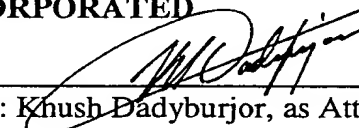
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IN WITNESS WHEREOF, the Parties have duly executed this Amendment as of the date first above written.

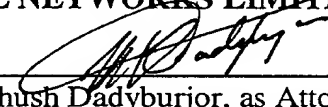
**NORTEL NETWORKS
CORPORATION**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

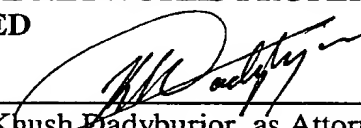
**NORTEL NETWORKS
INCORPORATED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

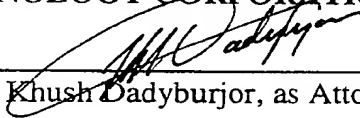
NORTEL NETWORKS LIMITED

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

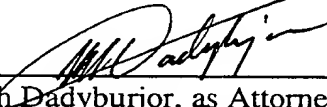
**NORTEL NETWORKS PROPERTIES
LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

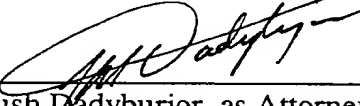
**NORTEL NETWORKS
TECHNOLOGY CORPORATION**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

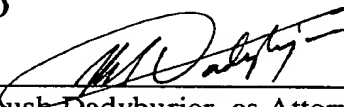
**NORTEL NETWORKS (ASIA)
LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

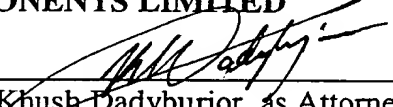
**NORTEL NETWORKS OPTICAL
COMPONENTS (SWITZERLAND)
GmbH**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

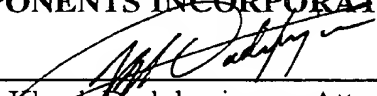
**NORTEL NETWORKS (U.K.)
LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

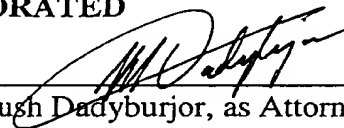
**NORTEL NETWORKS OPTICAL
COMPONENTS LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

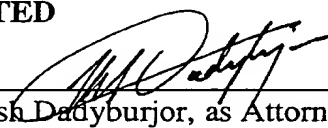
**NORTEL NETWORKS OPTICAL
COMPONENTS INCORPORATED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact


**NORTEL NETWORKS HPOCS
INCORPORATED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

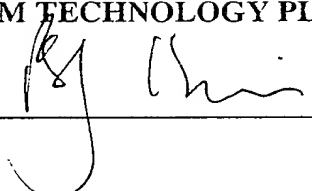
**NORTEL NETWORKS PHOTONICS
PTY LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

**NORTEL NETWORKS SHANNON
LIMITED**

By: 
Name: Khush Dadyburjor, as Attorney-in-Fact

BOOKHAM TECHNOLOGY PLC

By:  _____
Name:
Title:

On this 6th day of ~~December~~ ^{January}, 2003, before me appeared Klaus Dreyer, the person who signed this instrument, who acknowledged that he/she signed it as a free act on his/her own behalf or on behalf of the Assigning Parties with authority to do so.

Province ~~State~~ of Ontario)
)
 ~~Reg.~~ County of Peel)

ss. [Signature]

On this 18th day of December, 2002, before me appeared Philip Davis, the person who signed this instrument, who acknowledged that he/she signed it as a free act on his/her own behalf or on behalf of Bookham Technology plc with authority to do so.

State of Wimborne)
County of Cheshire) ss.

Stuart P. B. Capel

STUART P. B. CAPEL
SOLICITOR & NOTARY PUBLIC
6 EAST SAINT HELEN STREET
ABINGDON, OXON, OX14 5EW
TEL: 01235 - 523411
FAX: 01235 - 533283



SCHEDULE A

| Disc No. | Disclosure Title | City | Serial No. | Patent No. | Sub Status | All Inventors With Dept No's | Application Title |
|----------|---|------|------------|------------|------------|------------------------------|--|
| 10289RO | PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY | CA | 2,269,298 | | | | PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY |
| 10289RO | PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY | US | 09/294,114 | 6,222,200 | | | PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY |
| 10412RO | EXTERNAL CAVITY LASER | US | 09/688,873 | | | | EXTERNAL CAVITY LASER USING ANGLE-TUNED FILTER AND METHOD OF MAKING SAME |
| 10413ID | FIBRE TERMINATION COMPOUND GRADED INDEX LENSES | US | 09/750,874 | | | | FIBRE TERMINATION COMPOUND GRADED INDEX LENSES |
| 10485RO | ELECTRICALLY CONTROLLED OPTICAL ATTENUATOR WITH COPLANAR ELECTRODES | US | 09/726,409 | | | | ELECTROCHROMIC OPTICAL ATTENUATOR |
| 10509RO | ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS | US | 09/472,121 | 6,287,401 | | | ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS |
| 10509RO | ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS | CA | 2,328,279 | | | | ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS |
| 11006ID | MODULATOR ASSEMBLIES | US | 09/496,917 | | | | MODULATOR ASSEMBLIES |
| 11920ID | PUMPED OPTICAL AMPLIFICATION DEVICE | US | 09/557,891 | | | | PUMPED OPTICAL AMPLIFICATION DEVICE |
| 11945ID | A RAMAN FIBRE LASER | US | 09/573,238 | | | | A RAMAN FIBRE LASER |
| 11954ID | A RAMAN FIBRE LASER | US | 09/573,236 | | | | A RAMAN FIBRE LASER |
| 12242RO | INVERTED INP/INGAAS AVALANCHE PHOTODIODE | US | 09/733,060 | | | | EPITAXIALLY GROWN AVALANCHE PHOTODIODE |
| 12339ID | OPTICAL FIBER DEVICE | US | 09/653,985 | | | | OPTICAL FIBER DEVICE |
| 12349RO | COMPACT CHIP LABELING USING STEPPER TECHNOLOGY. | CA | 2,320,612 | | | | COMPACT CHIP LABELING USING STEPPER TECHNOLOGY |
| 12349RO | COMPACT CHIP LABELING USING STEPPER TECHNOLOGY. | US | 09/688,366 | | | | COMPACT CHIP LABELING USING STEPPER TECHNOLOGY |
| 12526RO | SELF ADJUSTING APPARATUS FOR GRIPPING AND MICRO-MANIPULATING CERAMIC SUBSTRATES | US | 09/660,542 | 6,409,241 | | | APPARATUS FOR GRIPPING CERAMIC SUBSTRATES |
| 12615ID | PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE | US | 09/676,256 | | | | PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE |
| 12634RO | BE DOPING OF INP | US | 09/741,350 | | | | STRUCTURE AND METHOD FOR DOPING OF III-V COMPOUNDS |
| 12665RO | PRINT QUALITY TEST STRUCTURE FOR DEVICE MANUFACTURING. | US | 09/667,620 | | | | PRINT QUALITY TEST STRUCTURE FOR LITHOGRAPHIC DEVICE MANUFACTURING |
| 12686ID | GLASS FIBER FIXATIVE AND FIXING PROCESS | US | 09/698,800 | | | | GLASS FIBER FIXATIVE AND FIXING PROCESS |
| 12715RO | METHOD OF MAKING GRATINGS ON TUNABLE LASER DEVICES | US | 09/667,622 | | | | METHODS FOR MAKING PATTERNS IN RADIATION SENSITIVE POLYMERS |

| Disc No. | Disclosure Title | Cty | Serial No. | Patent No. | Sub-Status | All Inventors with Dept. No's | Application Title |
|----------|--|-----|----------------|------------|--------------------|--|---|
| 12800AU | SPLIT-BEAM FOURIER FILTER | US | 08/793,729 | 5,930,441 | | | SPLIT-BEAM FOURIER FILTER |
| 12841ID | INTEGRATED OPTICAL TRANSMITTER | US | 09/616,659 | | | | INTEGRATED OPTICAL TRANSMITTER |
| 12847RO | BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER | CA | 2,328,641 | | | | CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER |
| 12847RO | BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER | US | 10/014,807 | | | | CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER |
| 12849ID | OPTICAL AMPLIFIER METHOD AND APPARATUS | US | 09/710,372 | | | | OPTICAL AMPLIFIER METHOD AND APPARATUS |
| 12849ID | OPTICAL AMPLIFIER METHOD AND APPARATUS | WO | PCT/GB01/04944 | | | | OPTICAL AMPLIFIER METHOD AND APPARATUS |
| 12948ID | OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE | US | 09/731,434 | | | | OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE |
| 12948ID | OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE | CA | 2,364,383 | | | | OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE |
| 13063CK | AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH | US | 08/726,049 | 6,041,071 | | | ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER |
| 13063CK | AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH | US | 60/004,620 | | | | AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH |
| 13063CK | AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH | US | 09/532,529 | | | | ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER |
| 13144CK | LASER WITH SETTABLE WAVELENGTHS | US | 0 | | Mailed Application | TAYEBATI, PARVIZ (7043-5010439), VAKHSHOORI, DARYOOSH (7068-5010442) | LASER WITH SETTABLE WAVELENGTHS |
| 13144CK | LASER WITH SETTABLE WAVELENGTHS | US | 60/099,252 | | | | LASER WITH SETTABLE WAVELENGTHS |
| 13144CK | LASER WITH SETTABLE WAVELENGTHS | US | 60/099,308 | | | | LASER WITH SETTABLE WAVELENGTHS |
| 13144CK | LASER WITH SETTABLE WAVELENGTHS | US | 09/386,604 | | | | LASER WITH SETTABLE WAVELENGTHS |
| 13144CK | LASER WITH SETTABLE WAVELENGTHS | CA | 2,317,133 | | | | LASER WITH SETTABLE WAVELENGTHS |
| 13199CK | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | US | 60/148,017 | | | | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13199CK | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | US | 09/636,817 | | | | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13199CK | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | WO | PCT/US00/21904 | | Nat'l Phase Filed | | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13199CK | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | CA | 2,381,662 | | | | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13199CK | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | EP | 973357.7 | | | | SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |

| Disc No | Disclosure title | Cy | Serial No | Patent No | Sub Status | All Inventors with Dept No's | Application title |
|---------|---|----|----------------|-----------|-------------------|------------------------------|--|
| 13201CK | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | US | 60/148,148 | | | | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13201CK | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | WO | PCT/US00/21905 | | Nat'l Phase Filed | | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13201CK | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | US | 09/636,807 | | | | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13201CK | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | CA | 2,381,665 | | | | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13201CK | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE | EP | 00957375.9 | | | | DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE |
| 13391RO | MONOLITHICALLY INTEGRATED OPTICALLY PUMPED EDGE EMITTING SEMICONDUCTOR LASER | US | 09/987,785 | | | | MONOLITHICALLY INTEGRATED OPTICALLY-PUMPED EDGE-EMITTING SEMICONDUCTOR LASER |
| 13417RO | GRATING ETCHING WITH INP MASKING | US | 09/750,124 | | | | METHOD OF ETCHING PATTERNS INTO EPITAXIAL MATERIAL |
| 13444CK | MICRORELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS | US | 09/859,938 | | | | MICRORELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS |
| 13444CK | MICRORELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS | WO | PCT/US01/14918 | | | | MICRORELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS |
| 13494ID | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN... | US | 09/821,580 | | | | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS |
| 13494ID | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN... | EP | 02251194.3 | | | | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS |
| 13494ID | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN... | CA | 2,374,557 | | | | METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS |
| 13495ID | OPTICAL MODULATORS | US | 09/679,165 | 6,377,717 | | | OPTICAL MODULATORS |
| 13502RO | ANGLED OUTPUT BALL TAPERED OPTICAL FIBER TERMINATION | US | 09/735,571 | | | | OPTICAL FIBER TERMINATION |
| 13524RO | A STATISTICAL MODEL USED TO CONTROL THE LASING WAVELENGTH OF SEMICONDUCTOR LASERS | US | 10/196,956 | | | | A METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR LASERS |
| 13544RO | SEMICONDUCTOR LASERS | US | 10/141,914 | | | | SEMICONDUCTOR LASER |
| 13584RO | ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING | US | 09/709,646 | | | | ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE |
| 13584RO | ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING | CA | 2,361,683 | | | | ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE |
| 13584RO | ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING | EP | 01309541.9 | | | | ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE |
| 13591ID | OPTICAL MODULATORS | GB | 0031241.3 | | | | OPTICAL MODULATORS |

| Disc No | Disclosure Title | Ctry | Serial No | Patent No | Sub Status | All Invents with Dept No's | Application Title |
|---------|--|------|-----------------|-----------|--------------------|---|---|
| 13591ID | OPTICAL MODULATORS | WO | PCT/GB01/05582 | | | | OPTICAL MODULATOR |
| 13614ID | OPTICAL PULSE GENERATION | US | 09/993,849 | | | | OPTICAL PULSE GENERATION |
| 13614ID | OPTICAL PULSE GENERATION | WO | PCT/GB02/03664 | | | | OPTICAL PULSE GENERATION |
| 13721RO | AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AND UNIFORMITY CROSS A WAFER | US | 0 | | Mailed Application | QIAN, YAHONG (C115-0531819,1), AN, SERGUEI (5C33-0510038,1) | AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AD UNIFORMITY CROSS A WAFER |
| 13813RO | HIGH POWER LASER DIODE AND METHOD OF FABRICATION THEREOF | US | 10/141,862 | | | | MONOLITHICALLY INTEGRATED HIGH POWER LASER OPTICAL DEVICE |
| 13816RO | APPARATUS FOR MONITORING THE OUTPUT POWER OF DIODE LASERS AND MODULATORS | | | | Unfiled | | |
| 14224ID | ISOLATION OF MICROWAVE TRANSMISSION LINES | US | 10/032,416 | | | | ISOLATION OF MICROWAVE TRANSMISSION LINES |
| 14404RO | HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER | US | 10/027,229 | | | | HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER |
| 14429ID | OPTICAL BEAM SAMPLING MONITOR | US | 10/006,509 | | | | OPTICAL BEAM SAMPLING MONITOR |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | CA | 2,292,769 | | | | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | EP | 99919257.8 | | | | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | JP | 11-552490 | | | | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | US | 09/063,173 | 6,204,560 | | | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | KR | 10-1999-7012042 | | | | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | WO | PCT/EP99/02665 | | Nat'l Phase Filed | | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |

| Disc No | Disclosure Title | Ctry | Serial No | Patent No | Sub Status | All Inventors with Dept No's | Application Title |
|---------|---|------|----------------|-----------|-------------------|---|---|
| 14433JD | TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD | JP | 0 | | | DAETWYLER, ANDREAS (-GPS4097856), DEUTSCH, URS (EXTR-GPS4097859), HARDER, CHRISTOPH (AA54-5050202), HEUBERGER, WILHELM (EXTR-GPS4097866), LATTI, ERNST-EBERHARD (EXTR-GPS4097878), JAKUBOWICZ, ABRAM (-GPS4097872), OOSENBURG, ALBERTUS (-GPS4097875) | A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METALLIZATION METHOD |
| 14434JD | STABILIZED LASER SOURCE | EP | 99810837.7 | | | | STABILIZED LASER SOURCE |
| 14434JD | STABILIZED LASER SOURCE | US | 10/049,886 | | | | STABILIZED LASER SOURCE |
| 14435JD | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT | EP | 99811030.8 | | | | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT |
| 14435JD | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT | WO | PCT/IB00/01530 | | Nat'l Phase Filed | | SUPPORTING STRUCTURE FOR OPTICAL FIBER FIXING AND SUBMICRON FINE ALIGNMENT |
| 14435JD | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT | US | PCT/IB00/01530 | | Nat'l Phase Filed | | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT |
| 14435JD | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT | CA | 2,390,916 | | Nat'l Phase Filed | | SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT |
| 14480RO | GAIN COUPLED DISTRIBUTED FEEDBACK LASER USING SELF-ASSEMBLED QUANTUM DOTS | | | | Unfiled | | |
| 14549JD | HIGH POWER SEMICONDUCTOR LASER DIODE | US | 09/852,994 | | | | HIGH POWER SEMICONDUCTOR LASER DIODE |
| 14549JD | HIGH POWER SEMICONDUCTOR LASER DIODE | CA | 2,385,653 | | | | HIGH POWER SEMICONDUCTOR LASER DIODE |
| 14549JD | HIGH POWER SEMICONDUCTOR LASER DIODE | EP | 2405380.3 | | | | HIGH POWER SEMICONDUCTOR LASER DIODE |
| 14549JD | HIGH POWER SEMICONDUCTOR LASER DIODE | JP | 2002-134066 | | | | HIGH POWER SEMICONDUCTOR LASER DIODE |
| 14551JD | CARRIER DESIGN FOR MODULES WITH HIGH POWER LASER DIODES | US | 10/026,150 | | | | HIGH POWER LASER CARRIER |
| 14552JD | ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS | US | 09/993,824 | | | | ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS |
| 14592ID | OPTICAL COMPONENT ALIGNMENT TECHNIQUE | US | 10/024,972 | | | | GIMBALLED LENS MOUNT AND ALIGNMENT ASSEMBLY FOR A SENSITIVE OPTICAL ALIGNMENT |
| 14676RO | ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN-COUPLED GRATINGS | US | 60/334,013 | | | | ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN-COUPLED GRATINGS |

| Disc No | Disclosure Title | Country | Serial No. | Patent No. | Sub Status | All Inventors with Dept. No's | Application Title |
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| 14676RO | ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN-COUPLED GRATINGS | US | 10/025,866 | | | | ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS COUPLED-COUPLED GRATINGS |
| 14681ID | THERMAL COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES | US | 10/032,421 | | | | THERMAL COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES |
| 14716RO | WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS | US | 10/073,101 | | | | WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS |
| 14794RO | A METHOD FOR MAKING FLOATING GRATINGS | US | 10/259,745 | | | | METHOD AND APPARATUS FOR FLOATING GRATINGS IN DFB (DISTRIBUTED FEEDBACK) LASERS |
| 14854RO | A METHOD FOR MINIMIZING CROSSTALK DUE TO LASER WAVELENGTH VARIATIONS WITH NON-IDEAL FILTERS | | | | Unfiled | | |
| 14864RO | POLARIZATION AND WAVELENGTH INDEPENDENT MHZ SPEED OPTICAL ATTENUATOR | US | 10/190,592 | | | | CURRENT TUNED MACH-ZEHNDER OPTICAL ATTENUATOR |
| 14942RO | RE-CIRCULATING OPTICAL PULSE GENERATOR | US | 10/116,168 | | | | RE-CIRCULATING OPTICAL PULSE GENERATOR |
| 15004RO | DEFORMABLE POLYMER MICRO MIRRORS (DPMM) | US | 10/098,446 | | | | MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS |
| 15004RO | DEFORMABLE POLYMER MICRO MIRRORS (DPMM) | US | 10/098,446 | | | | MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS |
| 15004RO | DEFORMABLE POLYMER MICRO MIRRORS (DPMM) | US | 10/098,446 | | | | MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS |
| 15093RO | MULTIPLE-CONTACT SEMICONDUCTOR OPTICAL AMPLIFIERS | US | 60/414,404 | | | | MULTIPLE-CONTACT OPTICAL AMPLIFIERS |
| 15095RO | FREQUENCY IDENTIFICATION WITH A FREQUENCY LOCKER | US | 10/108,856 | | | | FREQUENCY IDENTIFICATION WITH FREQUENCY LOCKER |
| 15113CK | METHOD TO IMPROVE TEMPERATURE STABILITY OF FREQUENCY LOCKER IN OPTOELECTRONIC MODULES | US | 10/165,465 | | | | WAVELENGTH STABILIZED OPTICAL DEVICE |
| 15116JD | NEW STRAIGHT-FLARED-STRAIGHT WAVEGUIDE DESIGN | US | 10/131,335 | | | | HIGH POWER SEMICONDUCTOR LASER DIODE AND METHOD FOR MAKING SUCH A DIODE |
| 15117JD | PUMP LASER DIODE WITH IMPROVED WAVELENGTH STABILITY | US | 0 | | | | *PUMP LASER DIODE WITH IMPROVED WAVELENGTH STABILITY |
| 15138ID | AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT | US | 10/161,523 | | | | AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT |

| Disc No | Disclosure Title | Cty | Serial No | Patent No | Sub Status | All Inventors with Dept No's | Application Title |
|---------|--|-----|------------|-----------|--------------------|--|---|
| 15142RO | SINGLE MODE, HIGH INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES | US | 60/352,572 | | | | FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS |
| 15142RO | SINGLE MODE, HIGH INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES | US | 60/352,572 | | | | FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS |
| 15150RO | METHOD FOR INTEGRATING A LASER WITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP | US | 0 | | Mailed Application | GLEW, RICK (C116-2819324), BETTY, IAN (5C33-0519725), GREENSPAN, JONATHAN (C116-0262541) | METHOD FOR INTEGRATING OPTICAL DEVICES IN A SINGLE EPITAXIAL GROWTH STEP |
| 15150RO | METHOD FOR INTEGRATING A LASER WITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP | US | 0 | | Mailed Application | GLEW, RICK (C116-2819324), BETTY, IAN (5C33-0519725), GREENSPAN, JONATHAN (C116-0262541) | METHOD FOR INTEGRATING OPTICAL DEVICES IN A SINGLE EPITAXIAL GROWTH STEP |
| 15164RO | A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER. | US | 0 | | Mailed Application | GLEW, RICK (C116-2819324), REID, BENOIT (5C32-0531388), LICHTENSTEIN, NORBERT L (AA55-5050260), FILY, ARNAUD (AA55-5053568) | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER |
| 15164RO | A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER. | US | 0 | | Mailed Application | GLEW, RICK (C116-2819324), REID, BENOIT (5C32-0531388), LICHTENSTEIN, NORBERT L (AA55-5050260), FILY, ARNAUD (AA55-5053568) | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER |
| 15181ID | LASER TRANSMITTER | US | 60/391,648 | | | | LASER TRANSMITTER |
| 15181ID | LASER TRANSMITTER | US | 60/391,648 | | | | LASER TRANSMITTER |
| 15193RO | OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER | US | 60/380,261 | | | | OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER |
| 15193RO | OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER | US | | | Mailed Application | EL-REFAEI, HATEM (5C33-0273812), JONES, TREVOR (C115-1342592.2), YEVICK, D (EXTR-GPS0380642.2) | OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER |
| 15320RO | ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP | US | 0 | | Mailed Application | PROSYK, KELVIN (5C33-0526051), BETTY, IAN (5C33-0519725) | ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP |
| 15338RO | HIGH POWER DISTRIBUTED FEEDBACK LASER | | | | Unfiled | | |
| 15386JD | RIDGE WAVEGUIDE LASER DIODE WITH COMPLEX INDEX GUIDING LAYER | US | 0 | | Mailed Application | TRAUT, SILKE (4212-5050415), SCHMIDT, BERTHOLD (AA54-5050359.4), SVERDLOV, BORIS (AA54-5050400.1), THIES, ACHIM (4212-5050409.1) | HIGH POWER SEMICONDUCTOR LASER DIODE AND METHOD FOR MAKING SUCH A DIODE |
| 15389JD | LASER STABILIZATION USING VERY HIGH RELATIVE FEEDBACK | | | | Unfiled | | |

| Disc No | Disclosure title | Cty | Serial No | Patent No | Sub Status | All Inventors With Dept. No's | Application title |
|---------|--|-----|------------|-----------|--------------------|--|--|
| 15390RO | ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE | US | 60/404,166 | | | | ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE |
| 15390RO | ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE | US | 60/404,166 | | | | ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE |
| 15399JD | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER | US | 60/390,882 | | | | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER |
| 15399JD | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER | US | | | Mailed Application | LICHTENSTEIN, NORBERT L (AA55-5050260), FIFY, ARNAUD (AA55-5053568,1), SCHMIDT, BERTHOLD (AA54-5050359,2), REID, BENOIT (5C32-0531388,2), KNIGHT, D. GORDON (C116-1529664,1) | A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER |
| 15502RO | A P-SUBSTRATE SELF-ALIGNED LASER STRUCTURE WITH IRON DOPED CURRENT BLOCKING LAYERS | | | | Unfiled | | |
| 15507RO | A MAGNETO-OPTIC NONRECIPROCAL WAVEGUIDE TE/TM MODE CONVERTER IN SEMICONDUCTING MATERIALS | | | | Unfiled | | |
| 15558RO | MANUFACTURE OF A GRATING TEMPLATE AND ITS TRANSFER INTO AL (IN, GA)AS MATERIAL USING IN-SITU ETCHING AND REGROWTH INSIDE A GROWTH REACTOR. | | | | Unfiled | | |
| 15592RO | ETCHING OF INDEX- OR GAIN-COUPLED GRATINGS INTO INGAASP MATERIAL USING IN-SITU ETCHING IN A GROWTH REACTOR | | | | Unfiled | | |
| 15649JD | LASER STRUCTURE WITH LARGE OPTICAL SUPERLATTICE WAVEGUIDE | | | | Unfiled | | |
| 15655RO | HIGH TEMPERATURE OPERATION LASER DIODES | | | | Unfiled | | |
| 15656RO | FABRICATION OF A BURIED HETEROSTRUCTURE LASER WITH AN INGAASP ACTIVE LAYER USING IN-SITU ETCHING IN A GROWTH REACTOR | | | | unfiled | | |
| HQ0054 | SUPERIMPOSED GRATING WDM TUNABLE LASERS | CA | 2,228,683 | 2,228,683 | | | SUPERIMPOSED GRATING WDM TUNABLE LASERS |
| HQ0054 | SUPERIMPOSED GRATING WDM TUNABLE LASERS | US | 09/253,129 | 6,141,370 | | | SUPERIMPOSED GRATING WDM TUNABLE LASERS |

| Disc No | Disclosure title | Ctry | Serial No | Patent No | Sub Status | All Inventors with Dept No's | Application title |
|---------|---|------|-------------|--------------|-------------------|------------------------------|---|
| ID0032 | OPTO ELECTRONIC COMPONENTS | US | 08/319,435 | 5,534,442 | | | OPTO ELECTRONIC COMPONENTS |
| ID0079 | SEMICONDUCTOR - SLICE CLEAVING | GB | 9216363.3 | 2 269 268 | | | SEMICONDUCTOR - SLICE CLEAVING |
| ID0079 | SEMICONDUCTOR - SLICE CLEAVING | US | 08/093,766 | 5,393,707 | | | SEMICONDUCTOR - SLICE CLEAVING |
| ID0094 | HYBRID OPTIC SOLUTION | DE | 95307824.3 | 695 04 280.7 | | | HYBRID OPTIC SOLUTION |
| ID0094 | HYBRID OPTIC SOLUTION | FR | 95307824.3 | 0 713 271 | | | HYBRID OPTIC SOLUTION |
| ID0094 | HYBRID OPTIC SOLUTION | GB | 9423282.4 | 2 295 265 | | | HYBRID OPTIC SOLUTION |
| ID0094 | HYBRID OPTIC SOLUTION | JP | 293046/1995 | | | | HYBRID OPTIC SOLUTION |
| ID0094 | HYBRID OPTIC SOLUTION | US | 08/560,312 | 5,668,823 | | | HYBRID OPTIC SOLUTION |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | FR | 94301114.8 | 0 614 214 | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | GB | 94301114.8 | 0 614 214 | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | DE | 69401370.6 | 69401370.6 | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | GB | 9303257.1 | 2 275 364 | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | JP | 6-45068 | | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0134 | SEMICONDUCTOR ETCHING PROCESS | US | 08/197,071 | 5,419,804 | | | SEMICONDUCTOR ETCHING PROCESS |
| ID0137 | PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS | GB | 9417975.1 | 2 293 248 | | | PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS |
| ID0137 | PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS | US | 08/507,613 | 5,574,811 | | | PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS |
| ID0170 | INJECTION LASER AND PHOTODIODE ASSEMBLY | US | 08/201,473 | 5,365,534 | | | INJECTION LASER AND PHOTODIODE ASSEMBLY |
| ID0193 | FILAMENT COOLER | GB | 9404290.0 | 2 287 244 | | | FILAMENT COOLER |
| ID0193 | FILAMENT COOLER | US | 08/388,151 | 5,568,728 | | | FILAMENT COOLER |
| ID0199 | CO & COUNTER-PUMPED OPTICAL AMPLIFIER | US | 08/303,367 | 5,542,011 | | | CO & COUNTER-PUMPED OPTICAL AMPLIFIER |
| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | US | 08/303,374 | 5,530,580 | | | ELECTRO ABSORPTION OPTICAL MODULATORS |
| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | EP | 94306216.6 | 0 643 317 | Nat'l Phase Filed | | ELECTRO ABSORPTION OPTICAL MODULATORS |
| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | GB | 9417001.6 | 2 281 785 | | | ELECTRO ABSORPTION OPTICAL MODULATORS |

| Disc No. | Disclosure title | Cn | Serial No. | Patent No. | Sub Status | All Inventors with Ident No's | Application title |
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| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | DE | 94306216.6 | 694 26 796.1 | | | ELECTRO ABSORPTION OPTICAL MODULATORS |
| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | FR | 94306216.6 | 0 643 317 | | | ELECTRO ABSORPTION OPTICAL MODULATORS |
| ID0206 | ELECTRO ABSORPTION OPTICAL MODULATORS | JP | 216309/94 | | | | ELECTRO ABSORPTION OPTICAL MODULATORS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | DE | 94305060.9 | 694 10 032.3 | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | FR | 94305060.9 | 0 636 912 | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | GB | 9315789.9 | 2 280 544 | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | GB | 94305060.9 | 0 636 912 | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | JP | 180288/94 | | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0216 | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS | US | 08/283,264 | 5,522,000 | | | PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS |
| ID0237 | DIRECT AMPLITUDE MODULATION OF LASERS | US | 08/216,301 | 5,502,741 | | | DIRECT AMPLITUDE MODULATION OF LASERS |
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | EP | 96301377.6 | 0 732 739 | Nat'l Phase Filed | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | JP | 52013/96 | | | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | US | 08/612,314 | 5,933,707 | | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | GB | 96301377.6 | 0 732 739 | | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | DE | 96301377.6 | 696 18 264.5 | | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |

| Disc. No. | Disclosure title | Cty | Serial No. | Patent No. | Sub Status | All inventors with Dept. Nos. | Application title |
|-----------|---|-----|----------------|--------------|-------------------|-------------------------------|---|
| ID0261 | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING | FR | 96301377.6 | 0 732 739 | | | IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING |
| ID0287 | POLARISATION-INSENSITIVE OPTICAL MODULATORS | DE | 195 28 165.9 | | | | POLARISATION-INSENSITIVE OPTICAL MODULATORS |
| ID0287 | POLARISATION-INSENSITIVE OPTICAL MODULATORS | GB | 9515400.1 | 2 291 979 | | | POLARISATION-INSENSITIVE OPTICAL MODULATORS |
| ID0287 | POLARISATION-INSENSITIVE OPTICAL MODULATORS | FR | 9509417 | 2723485 | | | POLARISATION-INSENSITIVE OPTICAL MODULATORS |
| ID0287 | POLARISATION-INSENSITIVE OPTICAL MODULATORS | US | 08/510,752 | 6,275,321 | | | POLARISATION-INSENSITIVE OPTICAL MODULATORS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | EP | 95308872.1 | 0 717 297 | Nat'l Phase Filed | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | GB | 9425022.2 | 2 296 101 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | US | 08/570,983 | 5,570,444 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | DE | 95308872.1 | 695 26 563.6 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | GB | 95308872.1 | 0 717 297 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | FR | 95308872.1 | 0 717 297 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0295 | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS | IT | 95308872.1 | 0 717 297 | | | OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS |
| ID0311 | OPTICAL AMPLIFIER | DE | 96308900.8 | 696 03 935.4 | | | OPTICAL AMPLIFIER |
| ID0311 | OPTICAL AMPLIFIER | EP | 96308900.8 | 0 779 689 | Nat'l Phase Filed | | OPTICAL AMPLIFIER |
| ID0311 | OPTICAL AMPLIFIER | IT | 96308900.8 | 0 779 689 | | | OPTICAL AMPLIFIER |
| ID0311 | OPTICAL AMPLIFIER | FR | 96308900.8 | 0 779 689 | | | OPTICAL AMPLIFIER |
| ID0311 | OPTICAL AMPLIFIER | GB | 9525766.3 | 2 308 222 | | | OPTICAL AMPLIFIER |
| ID0311 | OPTICAL AMPLIFIER | US | 08/760,175 | 5,872,649 | | | OPTICAL AMPLIFIER |
| ID0348 | LASERS | EB | PCT/GB96/01406 | | Nat'l Phase Filed | | LASERS |
| ID0384 | HERMETIC OPTICAL FIBRE FEED-THROUGH | GB | 9515004.1 | 2 303 467 | | | HERMETIC OPTICAL FIBRE FEED-THROUGH |
| ID0384 | HERMETIC OPTICAL FIBRE FEED-THROUGH | US | 08/684,128 | 5,664,043 | | | HERMETIC OPTICAL FIBRE FEED-THROUGH |

| ID# | Disclosure title | Ctry | Serial No | Patent No | Sub Status | All Inventors with Dep'ts | Application title |
|--------|---|------|-------------|--------------|-------------------|---------------------------|---|
| ID0426 | ETALON ARRANGEMENT | EP | 97305110.5 | | | | ETALON ARRANGEMENT |
| ID0426 | ETALON ARRANGEMENT | JP | 179766/1997 | | | | ETALON ARRANGEMENT |
| ID0426 | ETALON ARRANGEMENT | JP | 179766/1997 | | | | ETALON ARRANGEMENT |
| ID0426 | ETALON ARRANGEMENT | CA | 2,203,845 | 2,203,845 | | | ETALON ARRANGEMENT |
| ID0426 | ETALON ARRANGEMENT | US | 08/848,337 | 5,828,689 | | | ETALON ARRANGEMENT |
| ID0431 | SEMICONDUCTOR LASERS | DE | 97901693.8 | 697 00 830.4 | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | EP | 97901693.8 | 0 876 696 | Nat'l Phase Filed | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | FR | 97901693.8 | 0 876 696 | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | GB | 9601703.3 | 2 309 581 | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | GB | 97901693.8 | 0 876 696 | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | IT | 97901693.8 | 0 876 696 | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | JP | 526680/1997 | | | | SEMICONDUCTOR LASERS |
| ID0431 | SEMICONDUCTOR LASERS | US | 09/091,684 | 6,058,125 | | | SEMICONDUCTOR LASERS |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | EP | 97902473.4 | 0 879 435 | Nat'l Phase Filed | | SECURING AN OPTICAL FIBRE IN A V-GROOVE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | GB | 9602564.8 | 2 310 052 | | | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | JP | 528272/1997 | | | | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | US | 08/952,676 | 5,985,086 | | | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | DE | 97902473.4 | 697 10 047.2 | | | SECURING AN OPTICAL FIBRE IN A V-GROOVE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | IT | 97902473.4 | 0 879 435 | | | SECURING AN OPTICAL FIBRE IN A V-GROOVE |

| Disc No. | Disclosure Title | Cy | Serial No. | Patent No. | Sub Status | All Inventors with Dept. No.s | Application Title |
|----------|---|----|----------------|------------|-------------------|-------------------------------|---|
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | FR | 97902473.4 | 0 879 435 | | | SECURING AN OPTICAL FIBRE IN A V-GROOVE |
| ID0467 | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE | WO | PCT/GB97/00320 | | Nat'l Phase Filed | | CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE |
| ID0519 | SEMICONDUCTOR PHOTODETECTOR PACKAGING | JP | 507707/1998 | | | | SEMICONDUCTOR PHOTODETECTOR PACKAGING |
| ID0519 | SEMICONDUCTOR PHOTODETECTOR PACKAGING | US | 09/214,634 | 6,188,118 | | | SEMICONDUCTOR PHOTODETECTOR PACKAGING |
| ID0519 | SEMICONDUCTOR PHOTODETECTOR PACKAGING | CA | 2,258,178 | | | | SEMICONDUCTOR PHOTODETECTOR PACKAGING |
| ID0519 | SEMICONDUCTOR PHOTODETECTOR PACKAGING | EP | 97933796.1 | | | | SEMICONDUCTOR PHOTODETECTOR PACKAGING |
| ID0519 | SEMICONDUCTOR PHOTODETECTOR PACKAGING | WO | PCT/GB97/02053 | | Nat'l Phase Filed | | SEMICONDUCTOR PHOTODETECTOR PACKAGING |
| ID0651 | DIRECT AMPLITUDE MODULATION OF LASERS | EP | 98303274.9 | | | | DIRECT AMPLITUDE MODULATION OF LASERS |
| ID0651 | DIRECT AMPLITUDE MODULATION OF LASERS | US | 08/865,760 | 5,901,164 | | | DIRECT AMPLITUDE MODULATION OF LASERS |
| ID0651 | DIRECT AMPLITUDE MODULATION OF LASERS | CA | 2,235,179 | | | | DIRECT AMPLITUDE MODULATION OF LASERS |
| ID0651 | DIRECT AMPLITUDE MODULATION OF LASERS | JP | 146072/1998 | | | | DIRECT AMPLITUDE MODULATION OF LASERS |
| ID0687 | OPTICAL TRANSMITTER OUTPUT MONITORING TAP | US | 08/984,894 | 6,124,956 | | | OPTICAL TRANSMITTER OUTPUT MONITORING TAP |
| ID0691 | BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATES | US | 09/072,810 | 6,075,800 | | | BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATES |
| ID0764 | A REMOVABLY COATED OPTICAL FIBRE | US | 09/374,807 | 6,351,589 | | | REMOVABLY COATED OPTICAL FIBRE |
| ID0803 | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR | EP | 98309206.5 | | | | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR |
| ID0803 | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR | JP | 365470/1998 | | | | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR |
| ID0803 | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR | US | 08/997,752 | 5,956,437 | | | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR |
| ID0803 | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR | CA | 2,254,148 | | | | ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR |

| ID No. | Disclosure Title | Cty | Serial No. | Patent No. | Sub Status | All Inventors with Dept No's | Application Title |
|--------|--|-----|-------------|-------------|------------|------------------------------|--|
| ID0908 | SEMICONDUCTOR OPTO ELECTRONIC DEVICE PACKAGING | US | 09/070,899 | 6,407,438 | | | SEMICONDUCTOR OPTO-ELECTRONIC DEVICE PACKAGING |
| ID1107 | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES | EP | 00301124.4 | | | | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES |
| ID1107 | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES | US | 09/280,360 | 6,240,221 | | | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES |
| ID1107 | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES | CA | 2,299,794 | | | | INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES |
| ID8512 | INJECTION LASER PACKAGES | US | 06/514,066 | 4,615,031 | | | INJECTION LASER PACKAGES |
| ID8512 | INJECTION LASER PACKAGES | GB | 8317959 | 2 124 402 | | | INJECTION LASER PACKAGES |
| ID8850 | OPTICAL AMPLIFIERS | US | 06/888,274 | 4,720,684 | | | OPTICAL AMPLIFIERS |
| ID8850 | OPTICAL AMPLIFIERS | CA | 469,211 | 1,245,328 | | | OPTICAL AMPLIFIERS |
| ID8852 | MANUFACTURING OPTICAL FIBRE | US | 06/736,327 | 4,608,276 | | | MANUFACTURING OPTICAL FIBRE |
| ID8852 | MANUFACTURING OPTICAL FIBRE | CA | 482,229 | 1,261,632 | | | MANUFACTURING OPTICAL FIBRE |
| ID8960 | OPTICAL FIBRE MANUFACTURE | US | 06/940,232 | 4,735,648 | | | OPTICAL FIBRE MANUFACTURE |
| ID9003 | COATING OPTICAL FIBRES | DE | 85306977.1 | 356 83 25.2 | | | COATING OPTICAL FIBRES |
| ID9003 | COATING OPTICAL FIBRES | JP | 222908/85 | 2029150 | | | COATING OPTICAL FIBRES |
| ID9003 | COATING OPTICAL FIBRES | US | 06/782,930 | 4,631,078 | | | COATING OPTICAL FIBRES |
| ID9003 | COATING OPTICAL FIBRES | GB | 85306977.1 | 0 178 107 | | | COATING OPTICAL FIBRES |
| ID9003 | COATING OPTICAL FIBRES | CA | 492,574 | 1,226,411 | | | COATING OPTICAL FIBRES |
| ID9186 | LASER MANUFACTURE | US | 07/296,946 | 4,949,352 | | | LASER MANUFACTURE |
| ID9186 | LASER MANUFACTURE | GB | 8512321 | 2 175 442 | | | LASER MANUFACTURE |
| ID9209 | TUBE FURNACE | US | 06/858,617 | 4,748,307 | | | TUBE FURNACE |
| ID9312 | OPTICAL FIBRE MANUFACTURE | US | 06/896,518 | 4,793,840 | | | OPTICAL FIBRE MANUFACTURE |
| ID9312 | OPTICAL FIBRE MANUFACTURE | GB | 8520945 | 2 179 339 | | | OPTICAL FIBRE MANUFACTURE |
| ID9315 | OPTICAL FIBRE CABLE HAVING SLOTTED CORE | DE | 365 02 56.1 | 365 02 56.1 | | | OPTICAL FIBRE CABLE HAVING SLOTTED CORE |
| ID9315 | OPTICAL FIBRE CABLE HAVING SLOTTED CORE | FR | 86306868.0 | 0 216 548 | | | OPTICAL FIBRE CABLE HAVING SLOTTED CORE |

| Disc No | Disclosure title | Ctry | Serial No | Patent No | Sub Status | All inventors with Dept. No's | Application title |
|---------|---|------|------------|-------------|------------|-------------------------------|---|
| ID9315 | OPTICAL FIBRE CABLE HAVING SLOTTED CORE | GB | 86306868.0 | 0 216 548 | | | OPTICAL FIBRE CABLE HAVING SLOTTED CORE |
| ID9315 | OPTICAL FIBRE CABLE HAVING SLOTTED CORE | NZ | 217514 | 217514 | | | OPTICAL FIBRE CABLE HAVING SLOTTED CORE |
| ID9315 | OPTICAL FIBRE CABLE HAVING SLOTTED CORE | US | 07/636,902 | RE34,516 | | | OPTICAL FIBRE CABLE HAVING SLOTTED CORE |
| ID9379 | OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER | US | 06/934,440 | 4,772,086 | | | OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER |
| ID9379 | OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER | GB | 8530797 | 2 184 255 | | | OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER |
| ID9495 | LASER ARRAY | DE | 87302417.8 | 376 44 10.6 | | | LASER ARRAY |
| ID9495 | LASER ARRAY | JP | 129591/87 | 2511969 | | | LASER ARRAY |
| ID9495 | LASER ARRAY | US | 07/032,779 | 4,760,580 | | | LASER ARRAY |
| ID9552 | OPTICAL FIBRE CABLES | DE | 3883556.8 | 3883556.8 | | | OPTICAL FIBRE CABLES |
| ID9552 | OPTICAL FIBRE CABLES | FR | 88300817.9 | 0 278 648 | | | OPTICAL FIBRE CABLES |
| ID9552 | OPTICAL FIBRE CABLES | GB | 8703255 | 2 201 008 | | | OPTICAL FIBRE CABLES |
| ID9552 | OPTICAL FIBRE CABLES | US | 07/154,866 | 4,830,459 | | | OPTICAL FIBRE CABLES |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | DE | 88306994.0 | 388 13 01.7 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | FR | 88306994.0 | 0 304 182 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | GB | 8719590 | 2 208 944 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | GB | 88306994.0 | 0 304 182 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | NL | 88306994.0 | 0 304 182 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | SE | 88306994.0 | 0 304 182 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9604 | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER | US | 07/230,057 | 4,988,159 | | | FIBRE TAILED OPTO-ELECTRONIC TRANSDUCER |
| ID9617 | EDGE EMITTING LIGHT EMISSIVE DIODE | US | 07/239,403 | 4,937,638 | | | EDGE EMITTING LIGHT EMISSIVE DIODE |
| ID9661 | WAVEGUIDE TO OPTO-ELECTRONIC TRANSDUCER | GB | 8823873.8 | 2 213 957 | | | WAVEGUIDE TO OPTO-ELECTRONIC TRANSDUCER |

| Disc No | Disclosure title | Ctry | Serial No | Patent No | Sub Status | All Inventions with Dept No's | Application title |
|---------|---|------|--------------|--------------|------------|-------------------------------|--|
| ID9715 | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH... | DE | 690 20 050.1 | 690 20 050.1 | | | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH... |
| ID9715 | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH... | FR | 90305474.0 | 0 400 853 | | | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH... |
| ID9715 | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH... | GB | 8912458.0 | 2 232 260 | | | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH... |
| ID9715 | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH... | JP | 141220/1990 | 2991238 | | | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH... |
| ID9715 | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH... | US | 07/531,791 | 5,083,090 | | | CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH... |
| ID9716 | CARB ON COATING OF OPTICAL FIBRES | DE | 690 10 282.8 | 0 400 938 | | | CARB ON COATING OF OPTICAL FIBRES |
| ID9716 | CARB ON COATING OF OPTICAL FIBRES | FR | 90305776.8 | 0 400 938 | | | CARB ON COATING OF OPTICAL FIBRES |
| ID9716 | CARB ON COATING OF OPTICAL FIBRES | GB | 9011933.0 | 2 236 331 | | | CARB ON COATING OF OPTICAL FIBRES |
| ID9716 | CARB ON COATING OF OPTICAL FIBRES | JP | 141221/1990 | 2866707 | | | CARB ON COATING OF OPTICAL FIBRES |
| ID9716 | CARB ON COATING OF OPTICAL FIBRES | US | 07/531,859 | 5,062,687 | | | CARB ON COATING OF OPTICAL FIBRES |
| ID9731 | BONDING A SEMICONDUCTOR TO A SUBSTRATE | GB | 8818522.8 | 2 221 570 | | | BONDING A SEMICONDUCTOR TO A SUBSTRATE |
| ID9742 | OPTICAL FILTERS | GB | 8823078.4 | 2 223 324 | | | OPTICAL FILTERS |
| ID9750 | DIFFRACTION GRATING | DE | 68928711.9 | 0365125 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | FR | 89308702.3 | 0 365 125 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | GB | 8821898.7 | 2 222 891 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | IT | 22874/BE/98 | 0 365 125 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | US | 07/579,081 | 5,029,981 | | | DIFFRACTION GRATING |

| Disc No | Disclosure Title | Ctry | Serial No | Patent No | Sub Status | All Inventors with Dep't No's | Application Title |
|---------|--|------|-------------|--------------|------------|-------------------------------|--|
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | JP | 239789/1989 | 2889608 | | | DIFFRACTION GRATING |
| ID9750 | DIFFRACTION GRATING | NL | 89308702.3 | 0 365 125 | | | DIFFRACTION GRATING |
| ID9752 | VAPOUR PHASE PROCESSING | GB | 8823233.5 | 2 223 509 | | | VAPOUR PHASE PROCESSING |
| ID9763 | MULTICHANNEL CAVITY LASER | DE | 89312024.6 | 689 18 238.4 | | | MULTICHANNEL CAVITY LASER |
| ID9763 | MULTICHANNEL CAVITY LASER | FR | 89312024.6 | 0 370 739 | | | MULTICHANNEL CAVITY LASER |
| ID9763 | MULTICHANNEL CAVITY LASER | GB | 8827385.9 | 2 225 482 | | | MULTICHANNEL CAVITY LASER |
| ID9763 | MULTICHANNEL CAVITY LASER | US | 07/625,818 | 5,115,444 | | | MULTICHANNEL CAVITY LASER |
| ID9774 | INTEGRATED OPTICS ASYMMETRIC Y-COUPLER | GB | 8902391.5 | 2 227 854 | | | INTEGRATED OPTICS ASYMMETRIC Y-COUPLER |
| ID9806 | OPTICAL FIBRE CABLE | US | 07/544,678 | 5,082,380 | | | OPTICAL FIBRE CABLE |
| ID9837 | AERIAL OPTICAL FIBRE CABLE | US | 07/596,381 | 5,050,960 | | | AERIAL OPTICAL FIBRE CABLE |
| ID9856 | SEMICONDUCTOR OPTICAL SOURCE | GB | 8924725.8 | 2 237 654 | | | SEMICONDUCTOR OPTICAL SOURCE |
| ID9870 | RING LASER | FR | 90309362.3 | 0 419 059 | | | RING LASER |
| ID9870 | RING LASER | GB | 8921295.5 | 2 236 426 | | | RING LASER |
| ID9870 | RING LASER | DE | 69003780.5 | 0 419 059 | | | RING LASER |
| ID9870 | RING LASER | JP | 249922/1990 | 3004336 | | | RING LASER |
| ID9870 | RING LASER | US | 07/583,590 | 5,056,096 | | | RING LASER |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | FR | 90304772.8 | 0401971 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | CA | 2,013,849 | 2,013,849 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | DE | 90304772.8 | 0401971 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | EP | 90304772.8 | 0401971 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | US | 07/363,006 | 4,934,774 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |

| Disc No | Disclosure Title | Cty | Serial No | Patent No | Sub Status | All Inventors with Appl No's | Application Name |
|---------|---|-----|------------|-----------|------------|------------------------------|--|
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | US | 07/501,990 | 5,035,916 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0068 | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE | GB | 90304772.8 | 0401971 | | | OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE |
| MO0166 | A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM AN OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER | US | 08/710,775 | 5,703,980 | | | A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM A OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | CA | 2,209,548 | | | | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | EP | 97111629.8 | | | | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | JP | 9-185588 | | | | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | US | 08/677,922 | 5,793,913 | | | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | US | 09/079,480 | 6,158,901 | | | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| MO0167 | A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE | US | 09/584,792 | 6,391,214 | | | METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE |
| RE1009 | FIBER OPTIC COUPLER | CA | 476,580 | 1,258,787 | | | FIBER OPTIC COUPLER |
| RE1009 | FIBER OPTIC COUPLER | US | 07/442,878 | 4,950,046 | | | FIBER OPTIC COUPLER |
| RE1037 | OPTICAL SIGNAL MODULATORS | CA | 507,411 | 1,257,923 | | | OPTICAL SIGNAL MODULATORS |
| RE1037 | OPTICAL SIGNAL MODULATORS | US | 06/856,887 | 4,730,171 | | | OPTICAL SIGNAL MODULATORS |
| RO1624 | HERMETIC OPTICAL ATTENUATOR | US | 06/233,500 | 4,695,125 | | | HERMETIC OPTICAL ATTENUATOR |

| Disc No | Disclosure title | Cty | Serial No | Patent No | Sub Status | All Inventors with Depu No's | Application title |
|---------|---|-----|------------|-----------|------------|------------------------------|---|
| RO1807 | DIFFUSION EQUIPMENT | CA | 416,834 | 1,204,986 | | | DIFFUSION EQUIPMENT |
| RO1807 | DIFFUSION EQUIPMENT | US | 06/446,441 | 4,493,287 | | | DIFFUSION EQUIPMENT |
| RO1809 | A PLANAR NARROW-STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT | US | 06/448,383 | 4,530,099 | | | A PLANAR NARROW-STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT |
| RO1882 | MELT DISPENSING LIQUID PHASE EPITAXY BOAT | CA | 448,169 | 1,201,220 | | | MELT DISPENSING LIQUID PHASE EPITAXY BOAT |
| RO1882 | MELT DISPENSING LIQUID PHASE EPITAXY BOAT | US | 06/583,985 | 4,574,730 | | | MELT DISPENSING LIQUID PHASE EPITAXY BOAT |
| RO1903 | METHOD FOR SCREENING LASER DIODES | CA | 447,814 | 1,196,080 | | | METHOD FOR SCREENING LASER DIODES |
| RO1903 | METHOD FOR SCREENING LASER DIODES | US | 06/582,956 | 4,489,477 | | | METHOD FOR SCREENING LASER DIODES |
| RO1944 | PHASED LINEAR LASER ARRAY | CA | 465,981 | 1,238,707 | | | PHASED LINEAR LASER ARRAY |
| RO1944 | PHASED LINEAR LASER ARRAY | US | 06/663,424 | 4,661,962 | | | PHASED LINEAR LASER ARRAY |
| RO1961 | ZINC DIFFUSION INTO INDIUM PHOSPHIDE | CA | 495,084 | 1,290,656 | | | ZINC DIFFUSION INTO INDIUM PHOSPHIDE |
| RO1961 | ZINC DIFFUSION INTO INDIUM PHOSPHIDE | US | 07/243,138 | 4,889,830 | | | ZINC DIFFUSION INTO INDIUM PHOSPHIDE |
| RO1987 | DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE | CA | 483,077 | 1,238,973 | | | DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE |
| RO1987 | DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE | US | 06/673,644 | 4,660,207 | | | DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE |
| RO1994 | A SURFACE EMITTING LASER | CA | 474,029 | 1,238,971 | | | A SURFACE EMITTING LASER |
| RO1994 | A SURFACE EMITTING LASER | US | 06/701,839 | 4,675,877 | | | A SURFACE EMITTING LASER |
| RO2005 | A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER | US | 06/701,707 | 4,675,876 | | | A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER |
| RO2005 | A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER | CA | 474,030 | 1,238,972 | | | A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER |
| RO2268 | AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE | CA | 562,885 | 1,293,179 | | | AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE |
| RO2268 | AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE | US | 07/179,834 | 4,859,628 | | | AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE |

| Disc No. | Disclosure Title | Ctry | Serial No. | Patent No. | Sub Status | All Inventors with Dept. No's | Application Title |
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| RO2314 | MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES | US | 07/176,120 | 4,847,665 | | | MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES |
| RO2349 | GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY | US | 07/201,155 | 4,849,373 | | | GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY |
| RO2349 | GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY | CA | 568,369 | 1,313,107 | | | GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY |
| RO2461 | OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION | US | 07/369,883 | 4,969,712 | | | OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION |
| RO2468 | PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE | CA | 2,018,900 | 2,018,900 | | | PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE |
| RO2468 | PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE | US | 07/385,599 | 4,953,006 | | | PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE |
| RO2564 | LASER DIODE STRUCTURE | FR | 91908207.3 | 0 530 212 | | | LASER DIODE STRUCTURE |
| RO2564 | LASER DIODE STRUCTURE | DE | 91908207.3 | 691 07 845.9 | | | LASER DIODE STRUCTURE |
| RO2564 | LASER DIODE STRUCTURE | GB | 91908207.3 | 0 530 212 | | | LASER DIODE STRUCTURE |
| RO2564 | LASER DIODE STRUCTURE | US | 07/522,015 | 4,989,214 | | | LASER DIODE STRUCTURE |
| RO2579 | MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER | US | 07/582,464 | 5,050,953 | | | MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER |
| RO2579 | MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER | GB | 91185124 | 2 248 968 | | | MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER |
| RO2714 | APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS | US | 07/996,411 | 5,350,923 | | | APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS |
| RO2785 | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION | DE | 94915483.5 | 694 08 144.2 | | | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION |
| RO2785 | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION | FR | 94915483.5 | 0 708 930 | | | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION |

| Disc. No. | Disclosure Title | Ctry | Serial No. | Patent No. | Sub-Status | All Inventors with Ident. No's | Application Title |
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| RO2785 | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION | GB | 94915483.5 | 0 708 930 | | | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION |
| RO2785 | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION | JP | 7-504252-95 | 2691638 | | | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION |
| RO2785 | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION | US | 08/091,708 | 5,363,457 | | | OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION |
| RO2788 | METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES | US | 08/118,273 | 5,345,459 | | | METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES |
| RO2799 | GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION | US | 08/170,074 | 5,452,318 | | | GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION |
| RO2809 | METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES | US | 08/158,545 | 5,586,207 | | | METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES |
| RO2817 | CIRCULAR GRATING LASERS | US | 08/158,543 | 5,448,581 | | | CIRCULAR GRATING LASERS |
| RO2875 | CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING | US | 08/450,841 | 5,524,076 | | | CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING |
| RO2879 | SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE | US | 08/242,653 | 5,483,547 | | | SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE |
| RO2956 | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT | GB | 9513146.2 | 2 302 738 | | | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT |
| RO2956 | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT | JP | 8-188293 | | | | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT |
| RO2956 | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT | CA | 2,176,099 | 2,176,099 | | | SEMICONDUCTOR MODULATOR WITH A SHIFT |

| Disc No | Disclosure title | City | Serial No | Patent No | Sub Status | All inventors with Dept No's | Application title |
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| RO2956 | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT | US | 08/612,555 | 5,694,504 | | | SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT |
| RO2969 | METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL | US | 08/450,839 | 5,567,659 | | | METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL |
| RO2974 | MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY | US | 08/413,555 | 5,536,085 | | | MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY |
| RO2999 | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS | CA | 2,209,455 | | | | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS |
| RO2999 | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS | EP | 97304743.4 | | | | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS |
| RO2999 | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS | JP | 9-174942 | | | | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS |
| RO2999 | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS | US | 08/675,757 | 5,799,119 | | | COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS |
| RO3007 | BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER | US | 08/728,991 | 6,028,875 | | | BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER |
| RO3015 | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS | GB | 9700985.6 | 2 309 335 | | | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS |
| RO3015 | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS | JP | 9-009795 | | | | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS |
| RO3015 | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS | US | 08/977,371 | 5,960,014 | | | THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS |
| RO3066 | LASER DIODE AND METHOD OF FABRICATION THEREOF | US | 09/093,399 | 6,151,347 | | | LASER DIODE AND METHOD OF FABRICATION THEREOF |

| Disc No | Disclosure Title | Ctry | Serial No | Patent No | Sub Status | All Inventors with Dept No's | Application Title |
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| RO3090 | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR | CA | 2,220,240 | 2,220,240 | | | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR |
| RO3090 | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR | EP | 97308615.0 | | | | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR |
| RO3090 | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR | US | 08/745,168 | 5,778,113 | | | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR |
| RO3090 | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR | US | 09/057,602 | 5,991,471 | | | CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR |
| RO3092 | POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE | US | 08/686,355 | 5,777,793 | | | POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | CA | 2,209,558 | | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | EP | 97111630.6 | 0 818 859 | Nat'l Phase Filed | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | US | 08/680,284 | 5,825,792 | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | JP | 9-186204 | | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | GB | 97111630.6 | 0 818 859 | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | DE | 97111630.6 | 697 11 126.1 | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |
| RO3139 | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS | FR | 97111630.6 | 0 818 859 | | | WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS |

| Disc No. | Disclosure Title | Cty | Serial No. | Patent No. | Sub Status | All Inventors with Dept No's | Application Title |
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| RO3478 | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE | EP | 98307439.4 | | | | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE |
| RO3478 | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE | JP | 10-264323 | | | | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE |
| RO3478 | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE | US | 08/933,529 | 5,936,994 | | | TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE |
| RO3479 | DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION | US | 08/953,015 | 6,026,110 | | | DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION |
| RO3610 | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS | EP | 98310111.4 | | | | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS |
| RO3610 | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS | JP | 10-366380 | | | | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS |
| RO3610 | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS | US | 08/998,071 | 6,104,739 | | | SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS |
| RO3746 | ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION | US | 08/994,453 | 5,869,398 | | | ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION |
| RO3920 | HIGH ORDER GAIN COUPLED DFB LASERS | WO | PCT/CA99/01067 | | | | A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER |
| RO3920 | HIGH ORDER GAIN COUPLED DFB LASERS | CA | 2,310,604 | | | | A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER |
| RO3920 | HIGH ORDER GAIN COUPLED DFB LASERS | EP | 99973441.1 | | | | A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER |
| RO3920 | HIGH ORDER GAIN COUPLED DFB LASERS | JP | 2000-588867 | | | | A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER |

| Disc No. | Disclosure Title | Cty | Serial No. | Patent No. | Sub Status | All Inventors Within Dept No's | Application Title |
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| RO4144 | COMPACT PROGRAMMABLE MATRIX OF STRONGLY COMPLEX COUPLED DFB LASERS FOR WIDE AND CONTINUOUS SINGLE WAVELENGTH | US | 09/209,860 | 6,201,824 | | | STRONGLY COMPLEX COUPLED DFB LASERS SERIES |
| RO4324 | CONTINUOUSLY TUNABLE HIGH REPETITION RATE SHORT PULSE GENERATION USING DUAL MODE HIGHLY GAIN-COUPLED DFB LASER DIODES | US | 09/213,088 | | | | GENERATION OF SHORT OPTICAL PULSES USING STRONGLY COMPLEX COUPLED DFB LASERS |
| RO4416 | VARIABLE OPTICAL ATTENUATOR | US | 09/388,628 | 6,246,826 | | | VARIABLE OPTICAL ATTENUATOR WITH PROFILED BLADE |
| RO4504 | ACTIVE REFLECTION MODULATOR | US | 09/409,036 | | | | COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM |
| RO4504 | ACTIVE REFLECTION MODULATOR | WO | PCT/CA00/00856 | | Nat'l Phase Filed | | COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM |
| RO4504 | ACTIVE REFLECTION MODULATOR | CA | 2,351,381 | | | | COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM |
| RO4504 | ACTIVE REFLECTION MODULATOR | EP | 947728.2 | | | | COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM |
| RO4504 | ACTIVE REFLECTION MODULATOR | JP | 2001-527411 | | | | COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM |

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| 10163ID | SLOTTED MONOLITHIC OPTICAL WAVEGUIDES | CA | 2,311,961 | | | SLOTTED MONOLITHIC OPTICAL WAVEGUIDES |
| 10163ID | SLOTTED MONOLITHIC OPTICAL WAVEGUIDES | EP | 304657 | | | PHASE ADJUSTER USING SLOTTED, CONCATENATED WAVEGUIDES AND THERMO-OPTIC OR ELECTRO-OPTIC INSERTS |
| 10163ID | SLOTTED MONOLITHIC OPTICAL WAVEGUIDES | US | 09/346,320 | 6,424,755 | | SLOTTED MONOLITHIC OPTICAL WAVEGUIDES |
| 11550RO | HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH | CA | 2,355,450 | | | HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH |
| 11550RO | HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH | US | 09/672,703 | | | HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH |
| 12801AU | FIBRE OPTIC CIRCULATOR | EP | 96940631.3 | | | FIBRE OPTIC CIRCULATOR |
| 12801AU | FIBRE OPTIC CIRCULATOR | US | 08/942,601 | 6,014,475 | | FIBRE OPTIC CIRCULATOR |
| 12802AU | OPTICAL FILTERING METHOD AND DEVICE | CA | 2,318,674 | | | OPTICAL FILTERING METHOD AND DEVICE |
| 12802AU | OPTICAL FILTERING METHOD AND DEVICE | US | 09/660,147 | 6,466,704 | | OPTICAL FILTERING METHOD AND DEVICE |
| 12802AU | OPTICAL FILTERING METHOD AND DEVICE | WO | PCT/AU00/00735 | | | OPTICAL FILTERING METHOD AND DEVICE |
| 12803AU | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE | CA | 2,313,311 | | | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE |
| 12803AU | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE | EP | 202289.5 | | | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE |

| Disc No. | Disclosure title | Ctry | Serial No. | Patent No. | Sub-Status | Application title |
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| 12803AU | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE | US | 09/345,027 | 6,263,131 | | REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE |
| 12803AU | REFLECTIVE NON RECIPROCAL OPTICAL DEVICE | US | 09/610,601 | 6,415,077 | | REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE |
| 12804AU | WAVELENGTH DEPENDENT ISOLATOR | CA | 10/129828 | | Nat'l Phase Filed | WAVELENGTH DEPENDENT ISOLATOR |
| 12804AU | WAVELENGTH DEPENDENT ISOLATOR | US | PCT/AU00/01380 | | Nat'l Phase Filed | WAVELENGTH DEPENDENT ISOLATOR |
| 12804AU | WAVELENGTH DEPENDENT ISOLATOR | WO | PCT/AU00/01380 | | Nat'l Phase Filed | WAVELENGTH DEPENDENT ISOLATOR |
| 13240AU | POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE | US | 09/736,095 | | | POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE |
| 14081ID | FIBRE OPTICAL COMPONENT | US | 09/888,888 | | | FIBRE OPTICAL COMPONENT |
| 14669AU | VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE | US | 10/218,267 | | | VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE |
| 15087ID | AN OPTICAL GRATING DEVICE | US | 10/109,916 | | | AN OPTICAL GRATING DEVICE |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | DE | 95308065.2 | 695 27 251.9 | | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | EP | 95308065.2 | 0 713 109 | Nat'l Phase Filed | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | FR | 95308065.2 | 0 713 109 | | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | GB | 9521916.8 | 2 295 245 | | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | JP | 293047/1995 | | | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0190 | WAVELENGTH RESONANT FUSED FIBRE COUPLER | US | 08/557,857 | 5,703,976 | | WAVELENGTH RESONANT FUSED FIBRE COUPLER |
| ID0226 | OPTICAL WAVEGUIDE GRATINGS | GB | 9318670.8 | 2 281 787 | | OPTICAL WAVEGUIDE GRATINGS |
| ID0291 | OPTICAL WAVEGUIDE GRATING FILTER | DE | 95308201.3 | 695 25 223.2 | | OPTICAL WAVEGUIDE GRATING FILTER |
| ID0291 | OPTICAL WAVEGUIDE GRATING FILTER | EP | 95308201.3 | 0 713 110 | Nat'l Phase Filed | OPTICAL WAVEGUIDE GRATING FILTER |
| ID0291 | OPTICAL WAVEGUIDE GRATING FILTER | FR | 95308201.3 | 0 713 110 | | OPTICAL WAVEGUIDE GRATING FILTER |
| ID0291 | OPTICAL WAVEGUIDE GRATING FILTER | GB | 9523489.4 | 2 295 247 | | OPTICAL WAVEGUIDE GRATING FILTER |
| ID0291 | OPTICAL WAVEGUIDE GRATING FILTER | US | 08/558,709 | 5,638,473 | | OPTICAL WAVEGUIDE GRATING FILTER |
| ID0309 | BRAGG GRATINGS IN WAVEGUIDES | US | 08/647,795 | 5,730,888 | | BRAGG GRATINGS IN WAVEGUIDES |
| ID0355 | ALL-FIBRE OPTICAL FILTER | DE | 96302352.8 | 696 22 778.9 | | OPTICAL NOTCH FILTER MANUFACTURE |
| ID0355 | ALL-FIBRE OPTICAL FILTER | EP | 96302352.8 | 0 736 784 | Nat'l Phase Filed | OPTICAL NOTCH FILTER MANUFACTURE |

| Disc No | Disclosure Title | City | Serial No | Patent No | Sub-Status | Application Title |
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| ID0355 | ALL-FIBRE OPTICAL FILTER | FR | 96302352.8 | 0 736 784 | | OPTICAL NOTCH FILTER MANUFACTURE |
| ID0355 | ALL-FIBRE OPTICAL FILTER | GB | 96302352.8 | 0 736 784 | | OPTICAL NOTCH FILTER MANUFACTURE |
| ID0355 | ALL-FIBRE OPTICAL FILTER | US | 08/628,579 | 5,708,740 | | ALL-FIBRE OPTICAL FILTER |
| ID0421 | PLANAR WAVEGUIDES | US | 08/842,021 | 5,904,491 | | PLANAR WAVEGUIDES |
| ID0423 | PLANAR WAVEGUIDE CLADDING | US | 08/842,022 | 5,885,881 | | PLANAR WAVEGUIDE CLADDING |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | CA | 2,241,189 | | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | DE | 97906822.8 | 697 09 330.1 | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | EP | 97906822.8 | 0 891 570 | Nat'l Phase Filed | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | FR | 97906822.8 | 0 891 570 | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | GB | 9605320.2 | 2 311 145 | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | GB | 97906822.8 | 0 891 570 | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | IT | 97906822.8 | 0 891 570 | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | JP | 532348/1997 | | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | US | 09/101,276 | | | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0444 | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY | WO | PCT/GB97/00606 | | Nat'l Phase Filed | WAVEGUIDES TO PHOTODETECTOR ASSEMBLY |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | CA | 2,239,118 | | | WAVEGUIDE PAIR WITH CLADDING |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | DE | 97900292 | 697 02 299.4 | Nat'l Phase Filed | METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | EP | 97900292 | 0 873 531 | Nat'l Phase Filed | METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | FR | 97900292 | 0 873 531 | Nat'l Phase Filed | METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | GB | 97900292 | 0 873 531 | Nat'l Phase Filed | METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY |

| ID No. | Disclosure Title | Ctry | Serial No. | Patent No. | Sub Status | Application Title |
|--------|---|------|----------------|--------------|-------------------|---|
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | IT | 97900292 | 0 873 531 | Nat'l Phase Filed | METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | JP | 524974/1997 | | | WAVEGUIDE PAIR WITH CLADDING |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | US | 09/091,257 | 6,044,192 | | WAVEGUIDE PAIR WITH CLADDING |
| ID0449 | WAVEGUIDE PAIR WITH CLADDING | WO | PCT/GB97/00040 | | Nat'l Phase Filed | WAVEGUIDE PAIR WITH CLADDING |
| ID0509 | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. | CA | 2,211,244 | | | OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS |
| ID0509 | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. | GB | 9715185.6 | 2 316 185 | | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. |
| ID0509 | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. | JP | 209343/97 | | | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. |
| ID0509 | MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON. | US | 08/896,092 | 6,115,518 | | OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | CA | 2,282,939 | | | OPTICAL EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | DE | 99306728.9 | 699 01 419.0 | | OPTICAL GAIN EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | EP | 99306728.9 | 1 009 078 | Nat'l Phase Filed | OPTICAL GAIN EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | FR | 99306728.9 | 1 009 078 | | OPTICAL GAIN EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | GB | 99306728.9 | 1 009 078 | | OPTICAL GAIN EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | IT | 99306728.9 | 1 009 078 | | OPTICAL GAIN EQUALIZER |
| ID0997 | SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A. | US | 09/209,387 | 6,321,000 | | OPTICAL EQUALIZER |
| ID8550 | OPTICAL FIBRES | GB | 8230675 | 2 129 152 | | OPTICAL FIBRES |

| Disc No | Disclosure title | Cy | Serial No | Patent No | Sub Status | Application title |
|---------|--|----|-------------|-------------|------------|--|
| ID9170 | BEAM SPLITTER/COMBERS | CA | 500,513 | 1,288,267 | | BEAM SPLITTER/COMBERS |
| ID9170 | BEAM SPLITTER/COMBERS | GB | 8503506 | 2 170 920 | | BEAM SPLITTER/COMBERS |
| ID9170 | BEAM SPLITTER/COMBERS | US | 06/819,125 | 4,756,589 | | BEAM SPLITTER/COMBERS |
| ID9441 | DIRECTIONAL COUPLER | DE | 378 25 37.2 | 378 25 37.2 | | DIRECTIONAL COUPLER |
| ID9441 | DIRECTIONAL COUPLER | FR | 87302418.6 | 0 246 737 | | DIRECTIONAL COUPLER |
| ID9441 | DIRECTIONAL COUPLER | GB | 8612660 | 2 190 762 | | DIRECTIONAL COUPLER |
| ID9441 | DIRECTIONAL COUPLER | JP | 118687/87 | 2022576 | | DIRECTIONAL COUPLER |
| ID9441 | DIRECTIONAL COUPLER | US | 07/032,783 | 4,801,185 | | DIRECTIONAL COUPLER |
| ID9579 | GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS | GB | 8716382 | 2 207 254 | | GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS |
| ID9730 | DOPED ELEMENTS | GB | 8820848.3 | 2 222 400 | | DOPED ELEMENTS |
| ID9758 | "OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING" | GB | 8926061.6 | 2 238 396 | | "OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING" |
| RO2922 | POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ON BIREFRINGENCE COMPENSATION | US | 08/329,923 | 5,488,679 | | POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ON BIREFRINGENCE COMPENSATION |